

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10787368			
<b>Filing Date:</b>	26-Feb-2004			
<b>Title of Invention:</b>	METHOD OF FORMING AN UNDERLAYER OF A BI-LAYER RESIST FILM AND METHOD OF FABRICATING A SEMICONDUCTOR DEVICE USING THE SAME			
<b>First Named Inventor/Applicant Name:</b>	Hyun-Woo Kim			
<b>Filer:</b>	Frank Chau			
<b>Attorney Docket Number:</b>	8028-42 (SPX200304-0017US)			
Filed as Large Entity				
<b>Utility      Filing Fees</b>				
<b>Description</b>	<b>Fee Code</b>	<b>Quantity</b>	<b>Amount</b>	<b>Sub-Total in USD(\$)</b>
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
<b>Post-Allowance-and-Post-Issuance:</b>				
Utility Appt Issue fee	1501	1	1440	1440
Publ. Fee- early, voluntary, or normal	1504	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Extension-of-Time:</b>				
<b>Miscellaneous:</b>				
Printed copy of patent - no color	8001	2	3	6
<b>Total in USD (\$)</b>				<b>1746</b>